Electronic Supplementary Information

Influence of Halogen Substitutions on Rates of Charge Tunneling across

SAM-based Large-area Junctions

Gyu Don Kong,^a Miso Kim,^a Hyeon-Jae Jang,^a Kung-Ching Liao,^b and Hyo Jae Yoon^a*

^aDepartment of Chemistry, Korea University, Seoul, 136-701, Korea

^bDepartment of Chemistry and Chemical Biology, Harvard University, 12 Oxford Street,

Cambridge MA 02138, USA

*Corresponding Author E-mail: hyoon@korea.ac.kr

Experimental Details

Materials All reagents were used as supplied unless otherwise specified. All organic solvents were purchased from Sigma-Aldrich or Fisher while water was purified using a Millipore Q-POD water purification system. Bezenethiol (\geq 99%), *p*-fluorobenzenethiol (98%), *p*chlorobenzenethiol (97%), *p*-bromobenzenethiol (95%), benzyl mercaptn (99%), *p*-fluorobenzyl mercaptan (96%), *p*-chlorobenzyl mercaptan (98%), *p*-bromobenzyl mercaptan (98%), and high purity eutectic gallium-indium (EGaIn; 99.99%) were obtained from Sigma-Aldrich and used as supplied. *p*-Iodobenzenethiol and *p*-iodobenzyl mercaptan were synthesized following the methods reported in the literature.^{1, 2} All thiol derivatives were stored under N₂ atmosphere and <4 °C.

Characterization. ¹H and ¹³C{¹H} NMR spectra were recorded on a Bruker DPX 400 using CDCl₃ as a solvent and residual solvents as an internal standard. The contact angle measurements were performed using a contact angle measurement system (Ramé-Hart model 500-F1, Ramé-Hart Instrument Co.) at room temperature (20 - 25 °C) with ~20% relative humidity. The droplet volume for the measurement was ~10 µL. We characterized the SAMs with X-ray photoelectron spectroscopy (XPS; Thermo Scientific K-Alpha photoelectron spectrometer with Monochromatic Al K- α X-ray radiation (1.49 kV at base pressure ~10⁻⁹ Torr)).

Experimental Details for Preparation of SAMs. We prepared SAMs following the procedure reported previously.³ Toluene (anhydrous, 99.8%; Sigma-Aldrich) solution (3 mM) of each of $HS(p-C_6H_4X)$ molecules (X=F, Cl, Br, and I) was added to an amber-colored vial. The solution was sealed and degassed by bubbling N₂ through the solution for *ca.* 1 min. Ag^{TS} was washed

with pure toluene, and placed to the solution of the thiol with the exposed metal face up. The vial was then filled with N₂. After 3 h incubation at room temperature, the Ag^{TS} film with the SAM on it was removed from solution and rinsed by repeatedly dipping the chip into clean toluene (3 × 1 mL). The solvent on the SAM was then evaporated by blowing gently a stream of nitrogen over chip.

Experimental Details for Electrical Measurements.

Tip formation. EGaIn conical tip was formed following the method reported in the literature.⁴⁻⁶ To generate a conical tip of EGaIn for use as a top contact, a 10 μ L gas-tight syringe was filled with EGaIn (\geq 99.99%, Sigma-Aldrich). A drop of EGaIn was then pushed to the tip of the syringe needle, the hanging drop was brought into contact with a surface on which the EGaIn would stick (e.g., an oxidized Ag surface), and the needle gently pulled away from the drop using a micromanipulator. Upon breaking from the bulk EGaIn on the surface, a fine conical shaped tip was obtained. Tip was newly formed every three junctions. In cases that visible whiskers formed during tip fabrication, we discarded the tip and formed a new tip; therefore, our junction measurements were carried out using "selected" conical tips that did not contain observable filament during tip formation.

Junction Formation and Measurements. Junction formation and measurements were done following the method reported in the literature.⁴⁻⁶ A SAM on Ag^{TS} was gently brought into contact first with a gold metal electrode. Then using a micromanipulator, conical EGaIn tip was gently brought into contact with its own reflection on the Ag surface, at which point a conformal contact has been established between the SAM and the EGaIn tip. The contact area was derived

from measuring the diameter of the contact area at high magnification. Assuming a circular contact, the area was derived from the measured diameter from which the current densities were calculated. The contact and presence of a SAM was confirmed by running a single J-V scan after which 20 more scans were run if there was indication of contact and tunneling. The total number of working junctions versus those that shorted was used to calculate the yield (%) of working junctions. Junction measurements were done with 3-4 samples by multiple users.

Minor Discussions

Structure-Property Relations at the Top-interface in EGaIn Tunneling Junctions. The role of the top interface (the interface between the terminus (denoted as "X" in this work) of SAM and the Ga₂O₃ surface of EGaIn electrode) in charge transport across EGaIn-based junctions is not known exactly. In an effort to resolve this issue, Whitesides and coworkers^{3, 4, 7} have previously introduced many functional groups into the X region and used to examine effects of compositional changes at the X//Ga₂O₃ interface on the rates of charge tunneling across Ag^{TS}/S(CH₂)_nM(CH₂)_mX//Ga₂O₃/EGaIn junctions (where M is the middle moiety of the SAM, either -CH₂CH₂- or -CONH-).^{3, 8} Rather surprisingly, *J*(*V*) through these junctions was not significantly affected by structural variations at the X//Ga₂O₃ top interface that involve simple aromatic/aliphatic groups,³ uncharged polar groups having a wide range of dipole moments (0.5< μ <4.5),⁴ and Lewis acidic/basic groups capable of forming ionic and/or hydrogen bonds with the Ga₂O₃ surface.⁷

Characterization of HS(CH_2)_n(p- C_6H_4X) *Compounds*. All thiols were characterized using ¹H NMR spectroscopy (see Figures S7 - S15 for NMR spectra) prior to use for preparation of SAMs.

¹H NMR spectra for benzenethiol, *p*-fluoro- and *p*-chloro-benzenethiols, benzyl mercaptan, and *p*-fluoro-, *p*-chloro-, *p*-bromo- and *p*-iodo-benzyl mercaptans did not show peaks related to oxidized byproducts. Although bromine- and iodine-terminated benzenethiols (HS(p-C₆H₄Br) and HS(p-C₆H₄I)) were purified through silica-gel column chromatography (one spot in TLC analysis was confirmed during purification), ¹H NMR spectra for bromine- and iodine-terminated benzenethiols (HS(p-C₆H₄Br) and HS(p-C₆H₄I)) showed minor peaks in the aromatic region (7 - 8 ppm) that are indicative of formation of disulfide (not other oxidized products such as sulfonate, sulfone, and sulfoxide) in CDCl₃ during preparation of NMR sample (or during measurements). This small amount of disulfide did not provide defects or structurally different thiolates in SAMs that are detectable by XPS: characterization of Ag^{TS}/S(p-C₆H₄X) SAMs using XPS (see below) confirmed that all the S(p-C₆H₄X) SAMs we studied contain one type of sulfur corresponding to thiolate.

XPS Measurements of Ag^{TS}/S(p-C_6H_4X) Samples. XPS analysis was performed for surveying composition of SAMs: in particular, using XPS we wished to determine whether SAMs contain oxidized forms of thiolates such as sulfonate, sulfone, sulfoxide, or disulfide (due to easily oxidizable characteristic of arylthiols in the presence of oxygen gas). XPS spectra (Figure S1) for all of $Ag^{TS}/S(p-C_6H_4X)$ samples showed a single type of sulfur, i.e., thiolate ($2p_{3/2}$ and $2p_{1/2}$ in ~162 eV and ~163 eV),⁹ indicating that there were no detectable signals for oxidized byproducts (sulfonate, sulfone, disulfide, or sulfide).

The SAM of benzenethiolate showed the presence of other S2p peaks (as minor peaks) appearing in \sim 160.5 eV and \sim 161 eV, which are indicative of the unbound (physisorbed) thiol;⁹ we prepared multiple samples of benzenethiolate SAM and thoroughly rinsed them with pure

toluene several times but repeatedly observed the presence of XPS peaks of unbound thiol. The presence of small amount of unbound (i.e., mobile) thiols does not influence junction measurements: if the unbound thiols affect junction measurements, we would observe decrease in J(V) as compared to the molecular junction comprising a SAM of phenylene of similar thickness. Indeed, the mean value $(\log |J(-0.5V)|_{mean} = 2.5 \pm 0.3)$ of current density for the benzenethiolate SAM was compatible with that for the benzenecarboxylate SAM $(\log |J(-0.5V)| = 1.5 \pm 0.2)$ measured using the same EGaIn conical electrode.⁵ (It has been demonstrated in ref. 5 that replacing a thiolate anchoring group with a carboxylate group does not sifniciantly influence J(V)).

All of SAMs that we tested showed small oxygen peaks. We attribute these oxygen peaks to water molecules physisorbed on the surface of the SAM, not to the oxidized byproducts. (Note that none of SAMs studied in this work showed XPS peaks of sulfur atom(s) related to the oxidized byproducts.)

For the iodine-terminated SAM (S(p-C₆H₄I)) a set of small shoulder peaks (~619 eV and ~631 eV) was observed in the deconvoluted high resolution XPS spectrum for iodine atom (Figure S1). The ratio of integrated areas of these small peaks to the major peaks at ~621 eV and ~631 eV was ~0.18. The small peaks are attributed to the lowest dissociation energy of C-I bond among other C-X bonds, leading to thermal scission of C-I bond upon irradiation of X-ray beam or oxidative addition by silver surface that give semi-ionic C-I or Ag-I bonds.¹⁰⁻¹² These peaks are very small as compared to the other iodine peaks, and thus our junction measurements for Ag^{TS}/S(p-C₆H₄X)//Ga₂O₃/EGaIn junctions are dominated by majority of SC₆H₄I molecules.

Contact Angle Measurements of $Ag^{TS}/S(p-C_6H_4X)$ Samples. Static contact angles averaged from nine measurements for wetting by water (10 µL) ranged from 84° to 91° (Table S2 and Figure S16). The measured values of wettability for $Ag^{TS}/S(p-C_6H_4X)$ were similar to the reported values for *n*-alkanethiolates of similar length (~85° for *n*-pentanethiolate) on silver.¹³

Low Yields of Working Junctions at Applied Bias |V| > 0.5V. We found significantly decreased yields of working junctions when applied bias is > |0.5V|. For EGaIn-based tunneling junctions, shorter SAMs (e.g., shorter than *n*-octadecanethiolates) usually show significantly decreased yields of working junctions due to the disorder of SAM structure, and an increased electric field (larger than ~3 MV/m,¹⁴ a dielectric strength for air). Electrical short has nothing to do with the electronic structure (HOMO or LUMO) of molecules within junctions. They are related to the property of protective layer (Ga₂O₃ layer) in the EGaIn top electrode, and degree of structural disorder in SAM.⁶

Lower Yields of Working Junctions of $S(CH_2)_n(p-C_6H_4X)$ SAMs than n-Alkane-based SAMs. The yields of working junctions for $S(CH_2)_n(p-C_6H_4X)$ SAMs ranged from 67 to 71%. These were slightly lower than those (80 – 100%) for SAMs of long *n*-alkanes (SC₈ to SC₁₆). Plausible explanations for the lower yields of working junctions in SC₆H₄X SAMs are that i) thin $S(CH_2)_nC_6H_4X$ molecules are exposed to higher electric field than thick alkanes at ±0.5V, and/or ii) highly packed *n*-alkanethiolate SAMs show higher yields of working junctions than $S(CH_2)_n(p-C_6H_4X)$ SAMs.

Effects of Halogen Substitutions on the Shape of Tunneling Barrier. Polarizability is a physicalorganic parameter that represents how electron clouds of molecules respond to an external electric field: i.e., how well an electron cloud is distorted in response to an electric field applied. Incorporating easily polarizable molecules into molecular junctions, in principal, leads to instantaneous dipole moment in the presence of high electric field, Thus the halogen-terminated benzenethiolates we studied in this work may form such a dipole moment under a high electric field (~1GV/m for ~1 nm of SAM at 0.5V) and thus change the shape of tunneling barrier of the junction.

Halogens have a different principal quantum number (*n*) but the same electron configuration in the outmost orbital shell (i.e., np^5 ; n = 2 - 5). The similarity in the electron configuration and the discrepancy in the principal quantum number offer the opportunity to examine the effect of ionization energy that is associated, intuitively, with the energy of highest occupied molecular orbital HOMO, on the rate of charge tunneling.

Х	Polarizability $(\alpha, 10^{-24} \text{ cm}^3)^a$	Dipole moment $(\mu, D)^{b}$	Bond dissociation energy (kcal/mol) ^c	HOMO (eV) ^a	LUMO (eV) ^a
Н	10.3	0.00	113	-9.75	-0.40
F	10.3	1.60	126 ^b	-9.80	-0.027
Cl	12.3	1.69	96 ^b	-9.39	-0.063
Br	13.6	1.70	80 ^b	-9.81	-0.051
Ι	15.5	1.70	65 ^b	-9.04	-0.43

Table S1. Literature Values of Polarizability, Molecular Dipole, Length and HOMO/LUMO Levels for Monohalogenated Benzenes (as Model Structures for halogenated benzenes).

^aValues were obtained from the literature.¹⁵ ^bCRC Handbook of Chemistry and Physics (85th Edition, CRC Press) ^cHandbook of Bond Dissociation Energies in Organic Compounds.

X in $S(p-C_6H_4X)$	θ^{a}
Н	87.1 ± 3.4
F	87.3 ± 2.5
Cl	89.5 ± 2.9
Br	91.1 ± 2.7
Ι	84.1 ± 4.9

Table S2. Summary of Data of Contact Angle Measurements.

^aValue averaged from nine measurements; error range is based on σ (standard deviation).



Figure S1. XPS spectra for SAMs of $S(p-C_6H_4X)$ on template-striped silver substrate (Ag^{TS}).







Figure S2. Histograms of $\log |J|$ at ± 0.5 V for SAMs composed of benzenethiolates (S(*p*-C₆H₄X)) terminated with a hydrogen (a) or halogen atoms (b–e). (Data of shorts were excluded for clarity).

Figure S3. Histograms of $\log |J|$ at ± 0.5 V for SAMs composed of benzyl thiolates (SCH₂(*p*-C₆H₄X)) terminated with a hydrogen (a) or halogen atoms (b–e). (Data of shorts were excluded for clarity).



Benzyl Mercaptans Benzenethiols $HSCH_2(p-C_6H_4X)$ $HS(p-C_6H_4X)$ 250 a) 300 X = H X = H r_{mean} = 1.1 r_{mean} = 1.1 $N_{traces} = 464$ 250 N_{traces} = 420 200 σ**, = 1.1** σ**, = 1.0** Yield = 71% Yield = 71% 200 $\log |r|_{mean} = 0.05$ 150 log|*r*|_{mean} σ_{log|r|} = 0.03 150 100 = 0.05 100 $\sigma_{\log |r|} = 0.02$ 50 50 0 0 -1.0 -1.0 -0.5 0,0 0.5 1.0 -0.5 0.0 0.5 1.0 b) 350 300 X = F 200 X = F r_{mean} = 1.2 r_{mean} = 1.7 N_{traces}=590 N_{traces}=378 σ**, = 1.1** 160 250 σ**, = 1.1** Yield =82% Yield =78% 200 log|*r*|_{mean}=0.09 120 $\log |r|_{mean} = 0.2$ 150 σ_{log|/]}=0.03 80 σ_{logiri}=0.03 100 40 50 0↓--1.0 0-1.0 -0.5 0.0 0.5 1.0 -0.5 0.0 0.5 1.0 c) 250 X = CI 250 X = CI r_{mean} = 1.1 r_{mean} = 1.3 200 N_{traces} = 468 200 $N_{traces} = 420$ σ**, = 1.1** σ**, = 1.1** Yield = 100% Yield = 67% 150 counts counts 150 log|*r*|_{mean} = 0.1 $\log |r|_{mean} = 0.1$ 100 $\sigma_{\log |r|} = 0.03$ 100 | $\sigma_{log|r|} = 0.03$ 50 50 0 0↓ -1.0 -0.5 0.0 0.5 -0.5 0.5 1.0 -1.0 0,0 1.0 d) 300 X = Br 200 X = Br r_{mean} = 1.4 r_{mean} = 1.6 250 - N_{traces} = 504 N_{traces} = 378 σ**, = 1.1** 160 σ**, = 1.1** Yield = 67% Yield = 50% 200 $\log |r|_{mean} = 0.2$ 120 $\log |r|_{mean} = 0.2$ 150 $\sigma_{_{\rm log|r|}}=0.03$ $\sigma_{\log |r|} = 0.03$ 80 100 40 50 0∔___ -1.0 0 -0.5 0,0 0.5 1.0 -0.5 0.0 0.5 1.0 e) -1.0 350 200 X = I r_{mean} = 1.5 X = I r_{mean} = 1.5 300 N_{traces}=378 $N_{traces} = 468$ 160 σ**, = 1.1** σ, = 1.1 250 Yield =50% Yield = 75% 120 200 log|*r*|_{mean}=0.2 $\log |r|_{mean} = 0.2$ σ_{log|r|}=0.03 150 $\sigma_{\log |r|} = 0.02$ 80 100 40 50 0↓--1.0 0∔_ -1.0 -0.5 0.5 -0.5 0.0 0.5 1.0 0.0 1.0 log|r| log|r|

Ag^{TS}/S(CH₂)_n(*p*-C₆H₄X)//Ga₂O₃/EGaIn junctions. a) X=H and b-e) X=halogen.

Figure S4. Histograms of log-rectification ratio $(\log |r|, r = |J(+0.5 \text{ V})|/|J(-0.5 \text{ V})|)$ of

Figure S5. Shorting junction under higher bias than ± 0.5 V. The numbers and arrows indicate the sequence of voltage sweep.



Figure S6. Plots of values of $\log |J(+0.5V)|_{mean} \pm \sigma_{\log}$ for $Ag^{TS}/S(CH_2)_n(p-C_6H_4X)//Ga_2O_3/EGaIn$ (n=0, 1) junctions as a function of (a) polarizability (α , 10⁻²⁴ cm³) at 0V; (b) HOMO (eV); (c) LUMO (eV); and (d) dipole moment (μ , D). Values for benzene and monohalogenated benzenes (C_6H_6 and C_6H_5X as a model structure) were obtained from the literature¹⁵ and CRC Handbook of Chemistry and Physics (85th Edition).



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Figure S8. ¹H NMR spectrum for *p*-bromobenzenethiol in CDCl₃







Figure S10. ¹H NMR spectrum for *p*-fluorobenzenethiol in CDCl₃







Figure S12. ¹H NMR spectrum for *p*-fluorobenzyl mercaptan in CDCl₃



Figure S13. ¹H NMR spectrum for *p*-chlorobenzyl mercaptan in CDCl₃



Figure S14. ¹H NMR spectrum for *p*-bromobenzyl mercaptan in CDCl₃



Figure S15. ¹H NMR spectrum for *p*-iodobenzyl mercaptan in CDCl₃



Figure S16. Representative photographs for contact angle measurements using a drop of deionized water (10 μ L) on the surface of SAMs of Ag^{TS}/S(*p*-C₆H₄X).





a) X=H













References

- S. Butini, S. Gemma, M. Brindisi, G. Borrelli, A. Lossani, A. M. Ponte, A. Torti, G. Maga, L. Marinelli, V. L. Pietra, I. Fiorini, S. Lamponi, G. Campiani, D. M. Zisterer, S.-M. Nathwani, S. Sartini, C. L. Motta, F. D. Settimo, E. Novellino and F. Focher, *J. Med. Chem.*, 2011, 54, 1401–1420.
- 2. C. Amatore, S. Gazard, E. Maisonhaute, C. Pebay, B. Schöllhorn, J.-L. Syssa-Magalé and J. Wadhawan, *Eur. J. Inorg. Chem.*, 2007, 4035–4042.
- 3. H. J. Yoon, N. D. Shapiro, K. M. Park, M. M. Thuo, S. Soh and G. M. Whitesides, *Angew. Chem., Int. Ed.*, 2012, **51**, 4658-4661.
- 4. H. J. Yoon, C. M. Bowers, M. Baghbanzadeh and G. M. Whitesides, *J. Am. Chem. Soc.*, 2014, **136**, 16-19.
- 5. K.-C. Liao, H. J. Yoon, C. M. Bowers, F. C. Simeone and G. M. Whitesides, *Angew. Chem. Int. Ed.*, 2014, **53**, 3889-3893.
- 6. F. C. Simeone, H. J. Yoon, M. M. Thuo, J. R. Barber, B. Smith and G. M. Whitesides, *J. Am. Chem. Soc.*, 2013, **135**, 18131-18144.
- 7. C. M. Bowers, K.-C. Liao, H. J. Yoon, D. Rappoport, M. Baghbanzadeh, F. C. Simeone and G. M. Whitesides, *Nano Lett.*, 2014, **14**, 3521–3526.
- 8. M. M. Thuo, W. F. Reus, F. C. Simeone, C. Kim, M. D. Schulz, H. J. Yoon and G. M. Whitesides, *J. Am. Chem. Soc.*, 2012, **134**, 10876-10884.
- 9. D. G. Castner, K. Hinds and D. W. Grainger, *Langmuir*, 1996, **12**, 5083-5086.
- 10. B.-T. Teng, W.-X. Huang, F.-M. Wu, X.-D. Wen and S.-Y. Jiang, *Chem. Phys. Lett.*, 2008, **461**, 47-52.
- 11. H. J. Wu, H. K. Hsu and C. M. Chiang, J. Am. Chem. Soc., 1999, 121, 4433-4442.
- 12. H. F. Wang, X. Y. Deng, J. Wang, X. F. Gao, G. M. Xing, Z. J. Shi, Z. N. Gu, Y. F. Liu and Y. L. Zhao, *Acta Physico-Chimica Sinica*, 2004, **20**, 673-675.
- 13. M. M. Walczak, C. Chung, S. M. Stole, C. A. Widrig and M. D. Porter, *J. Am. Chem. Soc.*, 1991, **113**, 2370-2378.
- 14. M. Tencer, H.-Y. Nie and P. Berinia, J. Electrochem. Soc., 2009, 156, J386-J392.
- 15. M. Dimitriu, E. Filip and I. Humelnicu, *Rev. Chim. Bucuresti*, 2008, **59**, 1009-1013.